

10/519699

PATENT

Attorney Docket No. 211843-00032

DT01 Rec'd PCT/PTO 23 DEC 2004

IN THE U.S. PATENT AND TRADEMARK OFFICE

Application No.: Not yet received

Filing Date: 23 December 2004

Inventor(s): Horsky, et al.

Group Art Unit: Not yet received

Examiner Name: Not yet received

Customer No.: 27160

Title: An Ion Implantation Device and a Method
of Semiconductor Manufacturing by the
Implantation of Boron Hydride Cluster
Ions

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Before examining the above-identified case on the merits, please enter the following preliminary amendment.

Amendment to the Specification is reflected on page 2.

Remarks begin on page 3 of this paper.